Self-cooling cryogenicm icrocalorim etersm ade of SIN IS junctions

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A bstract

H igh quality low leakage SIN IS devices made of A LA M n-A l layers were fabricated for energy dispersive single photon detection. Information on di erent heat ow channels was extracted from the measured dynamics of detector signals due to X -ray events. At the optim um operation point, the extracted e ective electron tem perature decreased from 88 m K down to 43 m K due to self-cooling, roughly doubling the detector sensitivity.

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E nergy resolving single photon detectors are of great interest for astrophysics, material science, medical applications or any other eld, where high quantum e ciency paired with direct energy information are desirable. Cryogenic microcalorimeters based on normal metal { insulator { superconductor (N IS) junctions are very attractive and proven candidates for such high resolution detectors [1]. Essential requirements for N IS spectrometers are low barrier leakage currents and operation at low tem – peratures for a smallheat capacity of the absorber. The latter can be met or improved by the Peltierlike e ect of hot-electron tunneling [2,3,4]. The ef-

ciency of power transfer out of the absorber is increased by coupling the norm alm etal sym m etrically via two tunnel junctions in series [5] (SIN IS structure). Heat ow m echanism supon energy deposition are rejected by detector signal dynam ics.

W e have fabricated high quality SIN IS junctions by standard optical lithography and m etal evaporation deposition (see inset of Fig. 1 for schematic drawing). The superconducting electrodes were pure Aluminium (Al, 300 nm thick), whereas the norm alabsorber was Aldoped with 0.3{0.6% of M anganese (Mn, 10 {500 nm thick) in order to suppress Cooper pairing [6]. An additional Silver layer $(0.1\{8 \text{ m})$ was eventually deposited on top of the AM n absorber in order to increase absorption e ciency to X -rays. The native A 10 x form ing the tunnel barrier yielded excellent and highly stable device characteristics with very low leakage currents. The product of (single) junction area A and norm all resistance R_n was $n = R_n A = 0.6$ 40 k m² for di erent oxide thicknesses. Figure 1 shows current-voltage characteristics of a high n device together with its di erential resistance $R_d = @V = @I.$ The measured gap corresponds to twice the Algap ($_{A1} = 172$ eV). This fact and the perfect symmetry of the characteristics indicate no signi cant in uence of the Mn doping

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on tunneling current. Low leakage is required for current biased detector operation. From extrapolation of the voltage dependent low current R_d to V ! 0 we extract a device base temperature of $T_b = 88 \text{ m K}$, in spite of a cryostat temperature of about 50 m K. The elevated T_b is due to background blackbody radiation and the presence of a relatively powerful⁵⁵Fe X -ray source. The ratio of leakage resistance to R_n was 5:6 10 for the device in Fig.1 (representative for high $_n$ sam ples) and decreased m oderately for increasing barrier transparency (low er $_n$).

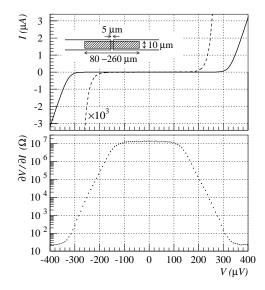


Fig.1. M easured current-voltage characteristics (solid line top graph) and corresponding di erential resistance (bottom) of a high $_n$ SIN IS device, a schem atic drawing of which is shown in the inset. The dashed line (top graph) represents the same data but with current scaled by 10^3 .

Upon energy deposition in the absorber and (presum ably quick) energy transfer to the electron system the heat ow is dom inated by [7]:

{ Electron-phonon coupling. The (hot) electrons relax to the (cold) phonon bath with a rate [8]

$$P_{e ph} = (T_{e}^{5} T_{b}^{5});$$
 (1)

where $3 nW K^{5} m^{3}$ is a material dependent coupling constant and is the absorber volume.

{ Hot-electron tunneling. The excess quasiparticles excited above the gap are extracted yielding the desired current signal. Power is rem oved irrespective of electrical current ow direction (i.e. through both junctions) and is approximately given (per junction) by

$$P_{tun} = \frac{I}{e} m ax (eV; kT):$$
 (2)

- { Backheating. Excitations which are not e ciently removed from the barrier region can leak back to the absorber volum e [7].
- { Power load from background radiation sources. Here we estimate $P_{\rm bg}=160\,pW$.

The therm alconductances G = dP = dT determ ine the time constants = C (T)=G of the relaxation processes, where C (T) = T is the electronic speci cheat and the Som m erfeld constant. We have investigated the dynam ics of detector signals due to X -ray events as shown in Fig.2 for two di erent bias voltages.

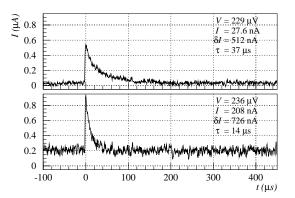


Fig.2. M easured SIN IS detector signals from X -ray events at two di erent operation points. Note the change in signal dynam ics (decay time).

For this type of experiment we have typically chosen low $_n$ devices since the self-cooling power is predicted [3] to increase with increasing barrier transparency, i.e. P_{tun} / R_n^{-1} . However, the junctions with the thinnest oxide barriers revealed a partial suppression of the gap on the superconducting electrode side due to proximity of the ferrom agnetic impurities (see IV in Fig. 3a). In order to keep the X-ray induced T and I variations sm all to maintain the simple model approach, a rather large (5 m thick) absorber volume was used. Detector signals were recorded over the bias voltage

range of su cient sensitivity and tted to the analyticalm odel to extract the (essentially exponential) pulse decay time, which is plotted in Fig. 3c.

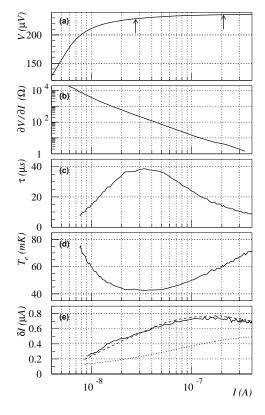


Fig. 3. (a) M easured IV characteristics of a low $_n$ SIN IS device at 88 m K. The deviation from exponential behaviour at low currents (< 10 nA) is due to leakage onset. The arrows indicate the operation points for the signals shown in Fig. 2. The abscissa was converted to display current (instead of bias voltage) for in proved visibility in the relevant range. (b) C orresponding di erential resistance. (c) D ecay time of measured detector signals upon deposition of 6 keV X-rays. (d) D educed e ective electron base tem – perature T_e of the absorber. (e) M easured current signal am plitude (solid line). The dashed line is a theoretical calculation assum ing an e ective T_e as shown in (d), whereas the dotted line assumes T_e = 88 m K.

Using Eqs. (1,2) and neglecting the e ect of backheating we can calculate an e ective T_e from

and for given device parameters, as shown in Fig.3d.D ue to its T_e^5 dependence the value of T_e is not very sensitive to modest variations of model parameters. In Fig.3e we plot the measured X-ray event signal amplitudes (solid line) together with

theoretical calculations using an electron tem – perature as determ ined in Fig. 3d (dashed line) as well as for $T_e = 88 \,\text{m K}$ (dotted line). Note the excellent agreement between experimental data and theory assuming a variable T_e , and the increase in sensitivity compared to a model without self-cooling. The e ect of microrefrigeration com – pensates (in our case) at least for the power load from background radiation.

In spite of the remarkable consistency between m easurements and our simple model, degradation due to backheating should in most cases be considered. Technically, the e ect can be reduced by very thick electrodes or implementation of trapping layers [9]. Furthermore, we observed an indication of incomplete thermalization and partial phonon escape from the absorber. This was re-

ected by a relatively poor spectral energy resolution of our devices. In provem ents are expected from deposition of the detector on a m em brane [1] or fabrication of a fully suspended absorber bridge with sm all junction areas.

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References

- M. Nahum and J.M. Martinis, Appl. Phys. Lett. 66 (1995) 3203.
- [2] H.L.Edwards, Q.Niu, and A.L. de Lozanne, Appl. Phys. Lett. 63 (1993) 1815.
- [3] M.Nahum, T.M. Eiles, and J.M. Martinis, Appl. Phys. Lett. 65 (1994) 3123.
- [4] D.Golubev and L.Kuzm in, J.Appl.Phys. 89 (2001) 6464.
- [5] M M.Leivo, J.P.Pekola, and D.V.Averin, Appl. Phys. Lett. 68 (1996) 1996.
- [6] S.T.Ruggiero et al., J.Low Tem p. Phys. 134 (2004) 973.
- [7] J.Jochum et al., J.Appl. Phys. 83 (1998) 3217.

- F.C.W ellstood, C.Urbina, and J.C larke, Phys. Rev. B 49 (1994) 5942.
- [9] J.P.Pekola et al, Appl. Phys. Lett. 76 (2000) 2782.